



10/607, 216.

PATENT

Attorney Docket No. 9108.0002

CFC

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re U.S. Patent No.: 7,214,595 B2 )  
Inventors: ATSUKO KAWASAKI ET AL. )  
Issue Date.: May 8, 2007 )  
For: METHOD OF PRODUCING )  
SEMICONDUCTOR DEVICES )

Certificate  
JUN 25 2007  
of Correction

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**REQUEST FOR CERTIFICATE OF CORRECTION**

Pursuant to 35 U.S.C. § 254, and 37 C.F.R. § 1.322, this is a request for a Certificate of Correction in the above-identified patent. The mistakes identified in the appended Form occurred through the fault of the Patent Office, as clearly disclosed by the records of the application which matured into this patent.

Two (2) copies of PTO Form 1050 are appended. The complete Certificate of Correction involves one (1) page. Issuance of the Certificate of Correction containing the correction is earnestly requested.

Please charge any required fees not included herewith to Deposit Account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

Dated: 6/21/07

By: [Signature]  
Richard V. Burgujian  
Reg. No. 31,744

JUN 26 2007

**UNITED STATES PATENT AND TRADEMARK OFFICE**  
**CERTIFICATE OF CORRECTION**

PATENT NO. 7,214,595 B2

Page 1 of 1

APPLICATION NO.: 10/607,216

ISSUE DATE: May 8, 2007

INVENTORS: Kawasaki et al.

It is hereby certified that an error or errors appear in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Claim 1, column 6, line 17, change "removing said film of the silicon oxide remaining inside" to --removing said film, except for residue of silicon oxide remaining inside--.

Claim 1, column 6, line 18, change "trench;" to --trench,--.

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